

JAN 09 2007

In re United States Patent Application of:		Docket No.:	020732-110.694
Applicant:	KORZENSKI, Michael B., et al.	Examiner:	AHMED, Shamim
Application No.:	10/807,858	Art Unit:	1765
Date Filed:	March 24, 2004	Confirm. No.:	5492
Title:	COMPOSITION USEFUL FOR REMOVAL OF BOTTOM ANTI-REFLECTION COATINGS FROM PATTERNED ION- IMPLANTED PHOTORESIST WAFERS		
		Customer No.:	24239

Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on January 9, 2007, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

Lillian Glenn

January 9, 2007
Date

AMENDMENT RESPONDING TO OCTOBER 24, 2006 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 10/807,858

**Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450**

Sir:

This responds to the October 24, 2006 Office Action in the above-identified application.

020732-110.694

Please amend the claims of the application as set out in the following **Section I (Amendments to the Claims)**.

Remarks addressing the substance of the October 24, 2006 Office Action are set out in the **Section II (Remarks)** hereof.